The Future of Your Career and Company: Avoiding the "Kodak Moment"

David Frigstad
Chairman
Frost & Sullivan

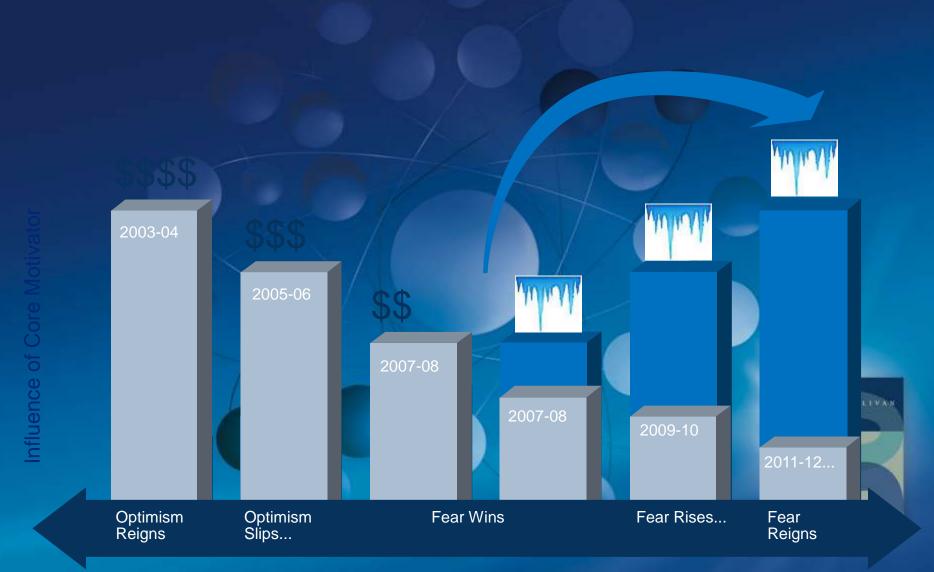








Fear Supercedes Optimism: Ten Year Retrospective



Continuum of Core Human Motivators



"If change is happening on the outside faster than on the inside the end is in sight."

- Jack Welch



Technology Analysis Dashboard

9 dimensions (cornerstone of technology selection) that eventually influence a technology to be a "market show stopper" rather than a "technology gimmick"

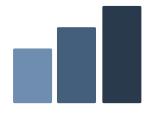
Year of Impact



IP Intensity



Market Potential



Funding



Global Footprint



Breadth of Industries



Megatrend Impact



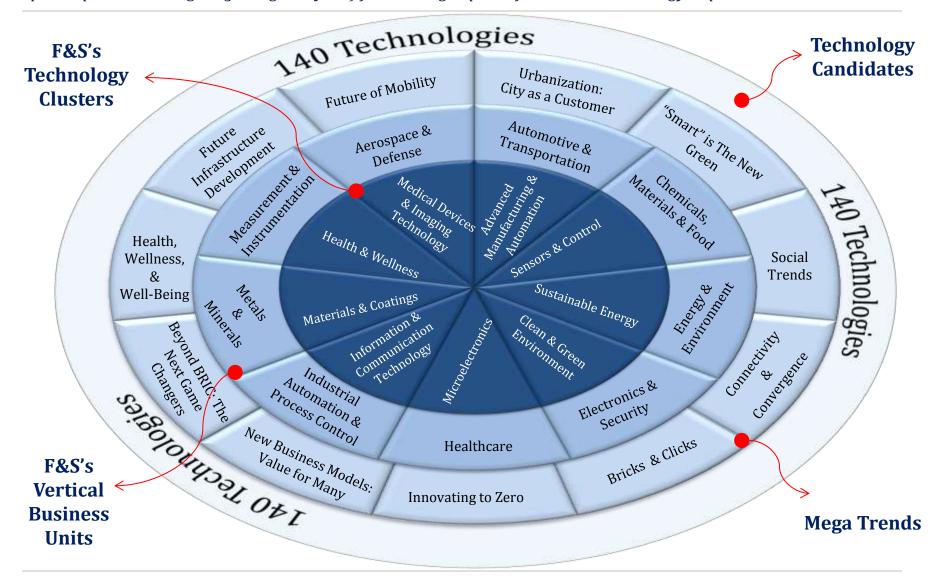
Potential Points of Convergence Size of Innovation Ecosystem





Innovation driven future world!

As part of the TechVision psyche, we look at "technology cluster \leftrightarrow market \leftrightarrow trend" interplay to evaluate and pick top 50 technologies (for a given year) from a larger pool of 140 or so technology capabilities



Regenerative Medicine
Next-Gen Sequencing
Biomarkers
Personalized Medicine
Targeted Drug Delivery
Genetic Cosmetics

Virtualization
Cloud Computing
Big Data Analytics
Semantic Search

Data Visualization Context-Aware Mobility Augmented Reality In-Memory Computing

Medical Device & Imaging Technology

> Remote Patient Monitoring Surgical Robots Interventional Radiology Neuromodulation Technologies

Advanced Manufacturing & Automation

Roll-to-Roll Manufacturing
3D Printing
Composites Manufacturing
Micromanufacturing

Sensors & Controls

CBRNE Detection
Energy Harvesting
Nanosensors
Ubiquitous Wireless Sensor

Information & Communication Technology

Health & Wellness

Sustainable Energy

Advanced Energy Storage Concentrated Solar Power Wind Power Grid Energy Management Superconductors

Clean &

Green Environment

Waste-to-Energy Advanced Filtration Solid Waste Treatment Biochemicals Desalination Technologies

Web

Materials & Coatings

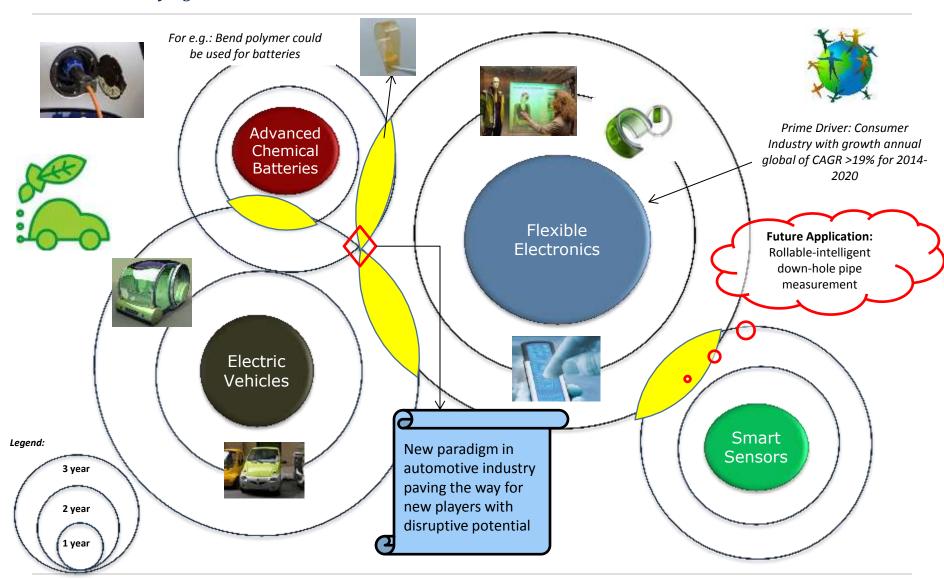
Microelectronics

General Illumination LEDs
Energy Efficient Processors
Next-Gen Non-Volatile Memory
Smart Haptics & Touch
Flexible Electronics
OLED Displays

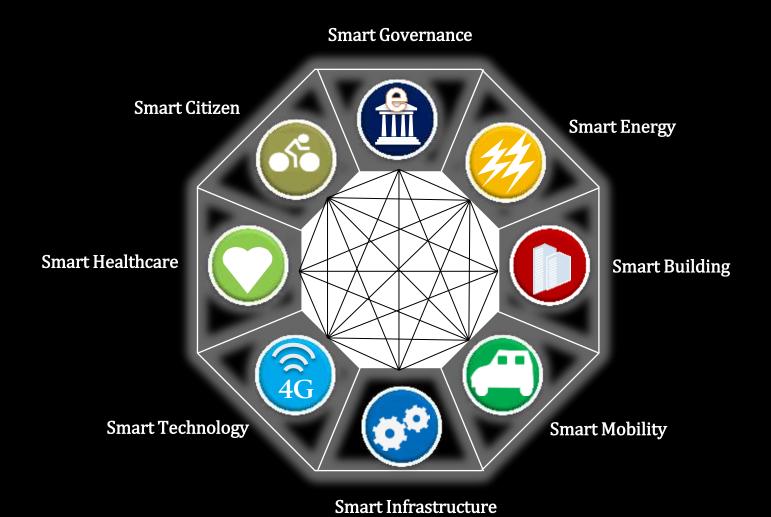
Carbon Fibers
Biocomposites
Superhydrophobic Coatings
Smart Packaging
Lightweight Composites
Polymer Chameleons
Alternative Feedstocks
Nanocoatings

Waves of Convergence!!!

Evolution of technologies at different rates gives rise to various waves of innovation that impact industries and markets at varying times

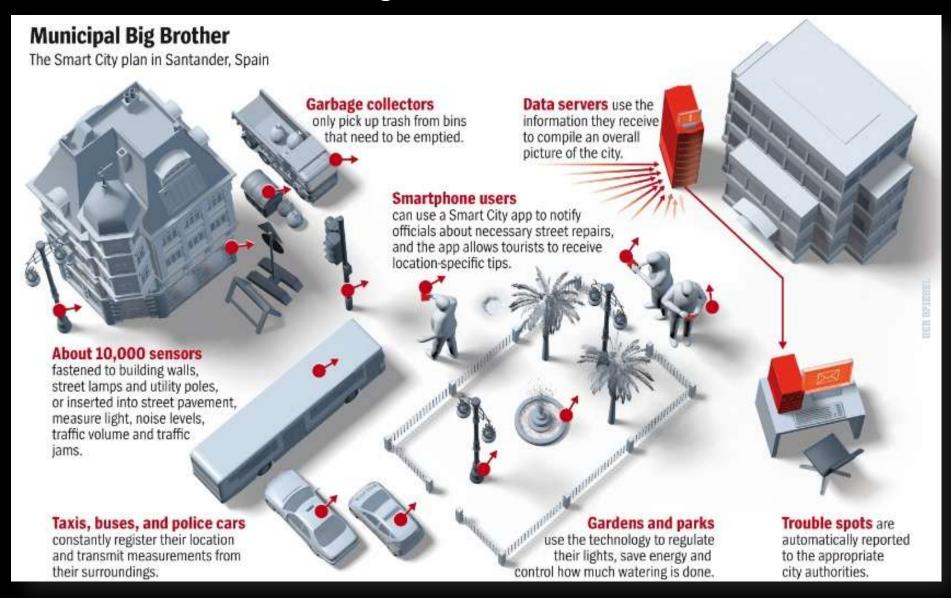


Smart Diamond that Defines a Smart City

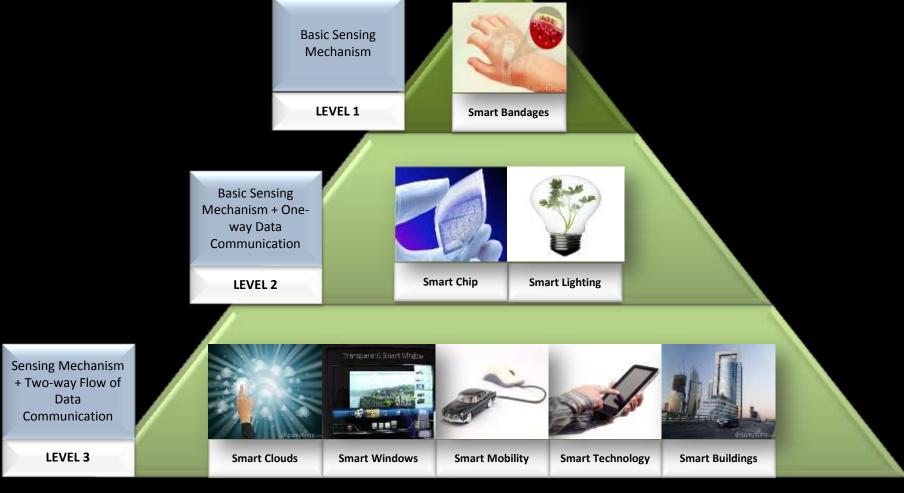


FROST & SULLIVAN

Case Study of SMART City Plan: In Santander, Spain 10,000 sensors feed BIG DATA into Data Servers that Integrates Various Infrastructure

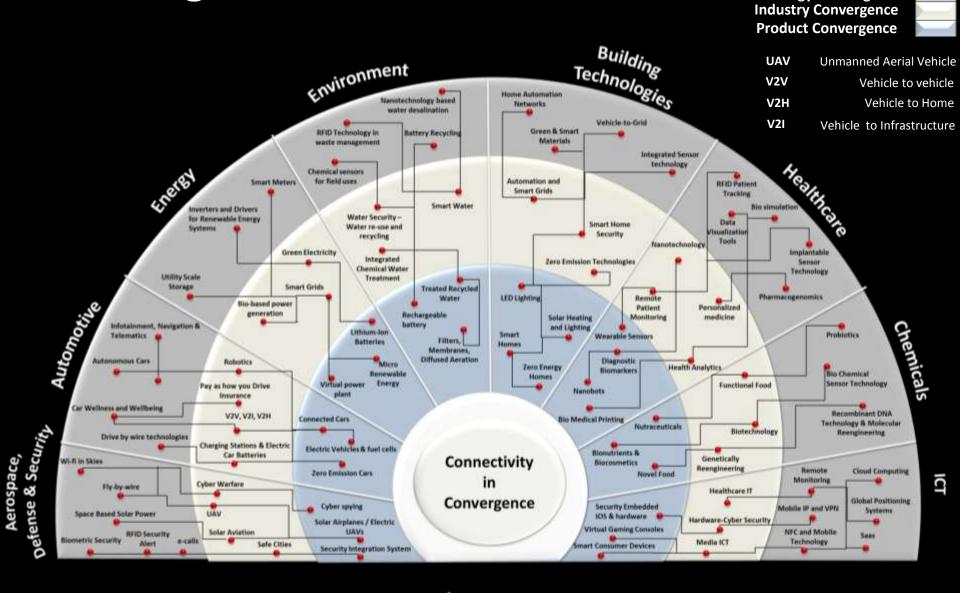


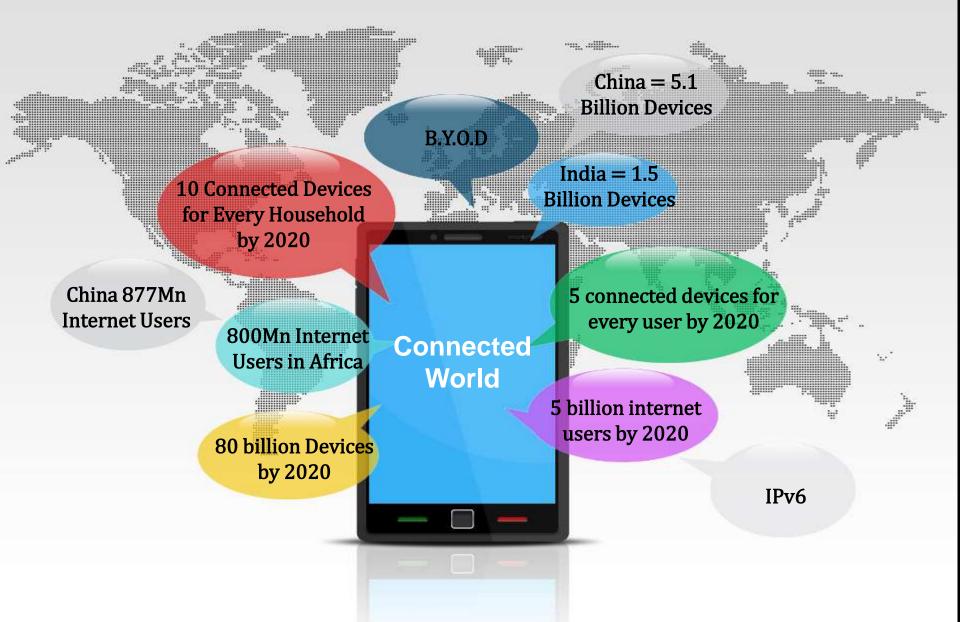
SMART is the new Green!!





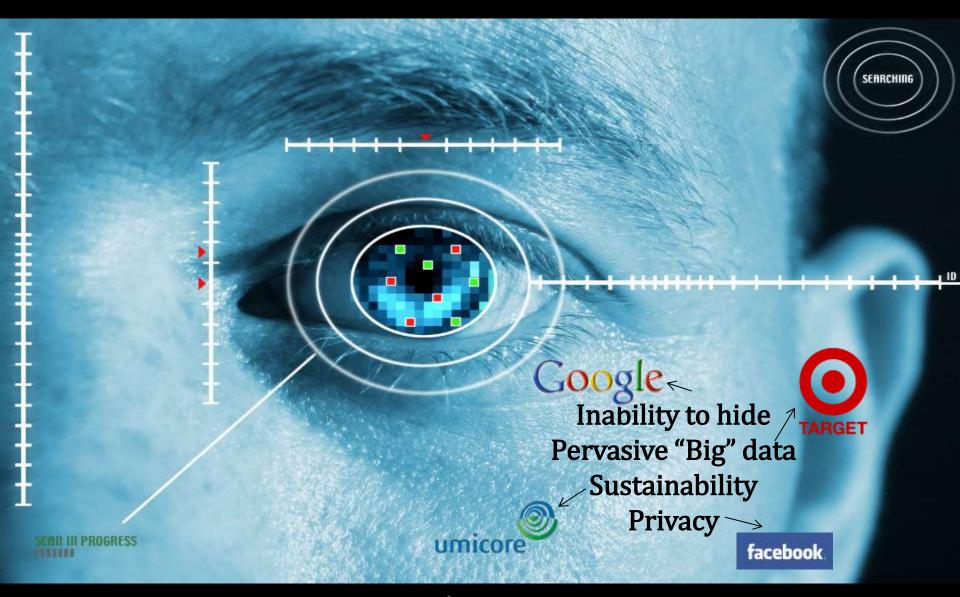
Connectivity will Lead to Convergence of Products, Technologies and Industries Technology Convergence





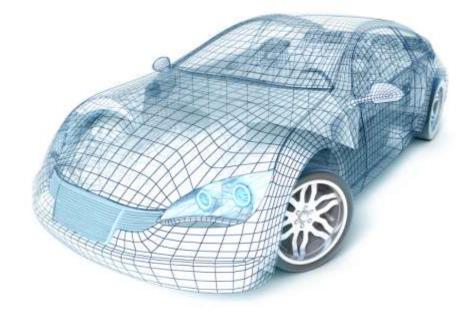
340,282,366,920,938,463,463,374,607,431,768,211,456

Transparency

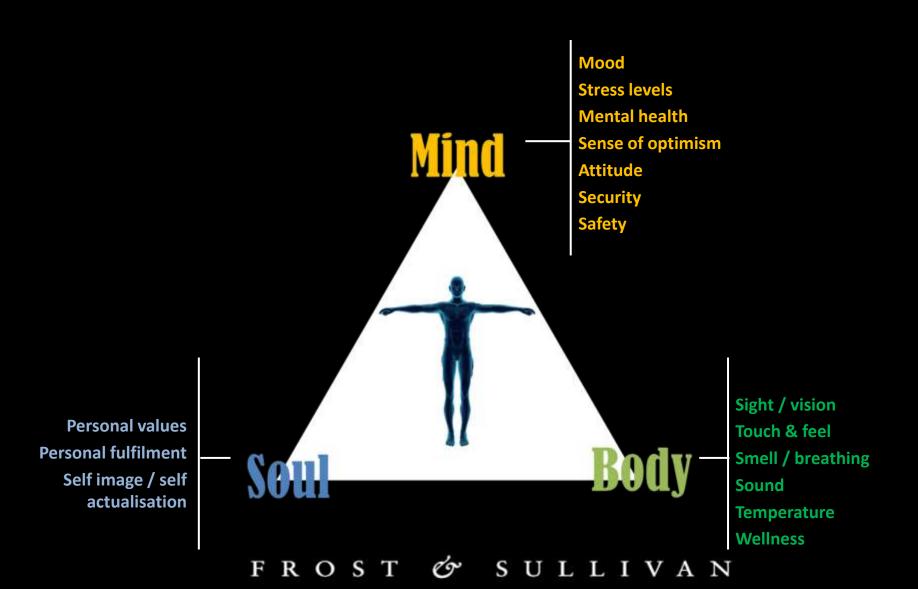




Mobility

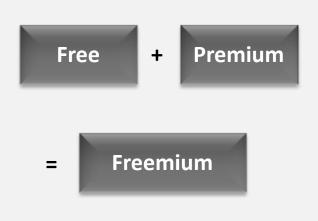


The 3 Cornerstones - The Body, Mind and Soul -



New Business Models:





"Value for Many"



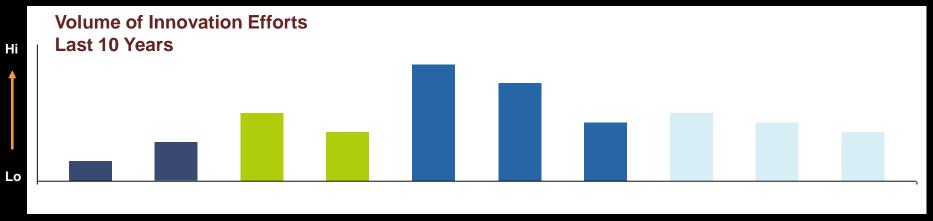
Will Replace

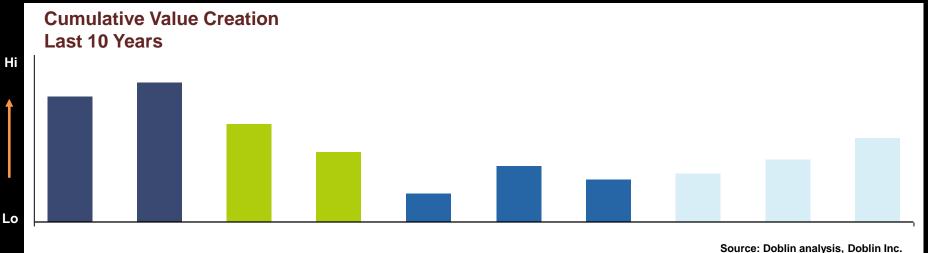


"Value for Money"

Business Model Focus Creates Higher Rate of Return

Strategy		Process		Product			Delivery		
Business model	Partnering	Enabling process	Core process	Product performance	Product system	Service	Channel	Brand	Customer experience







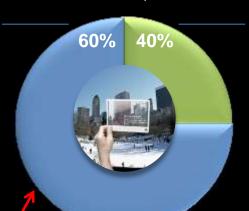
Total Augmented Reality Market to Hit \$75.2 Billion in 2020,

Augmented Reality, Global Revenue, 2020

Total AR Market: \$75.2 Billion

Mobile AR Augmented reality embedded mobile apps

\$45 Billion



Others

Heads Up Displays & Head **Mounted Displays**

\$30.2 Billion



Reality



Augmented Reality



Augmented Virtuality



Virtual World

Photocredits: : Dreamstime

Source: : Frost & Sullivan, 2012

Your Next Step



The Convergence of 450mm, 22/14nm, EUV, and 3D (FinFET - NAND) Structures and its Impact on the Semiconductor Equipment Industry

AROOP ZUTSHI

FROST & SULLIVAN

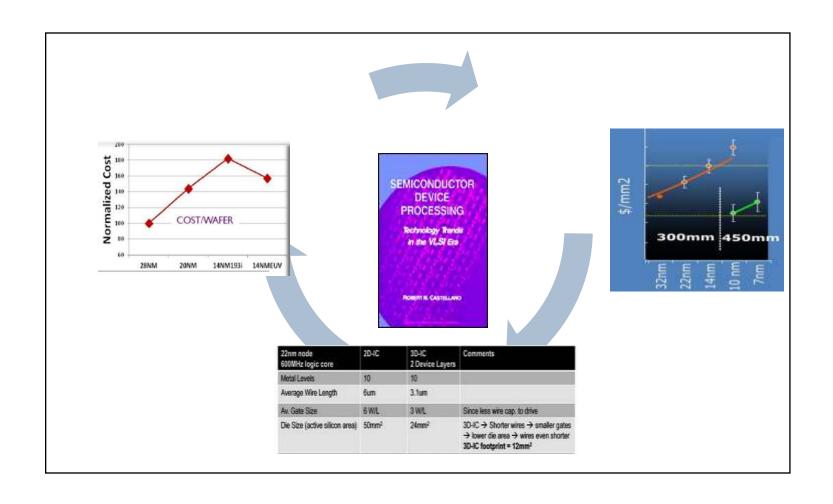
November 2013



Convergent and disruptive

We are entering the most dynamic period that, I have witnessed in the 30 years of analyzing the semiconductor industry !!!!

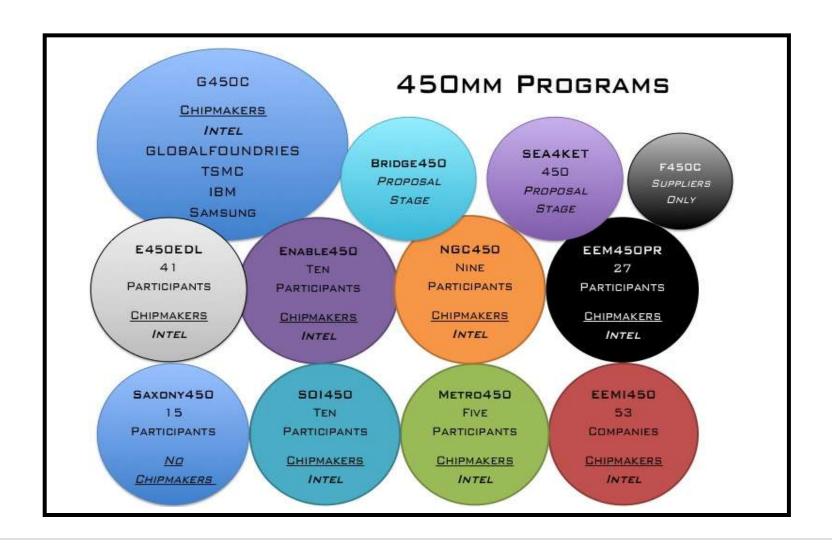
It's all about timing



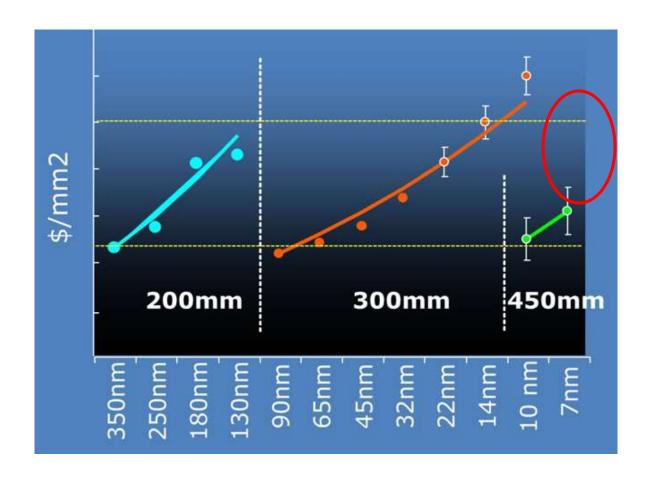
450mm Wafers

Why?
When?
What are the Implications?

Intel is the catalyst behind 450mm through several consortia

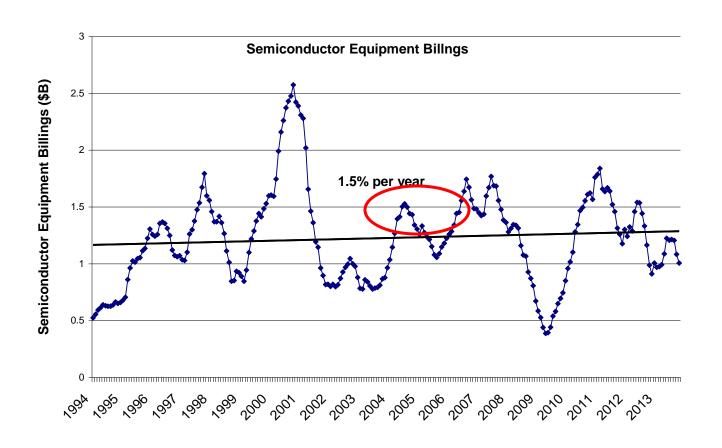


Why? Reduced costs entering the sub 14nm node

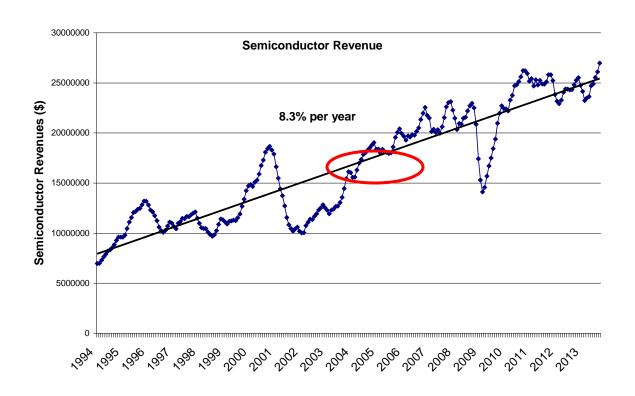


Source: Intel

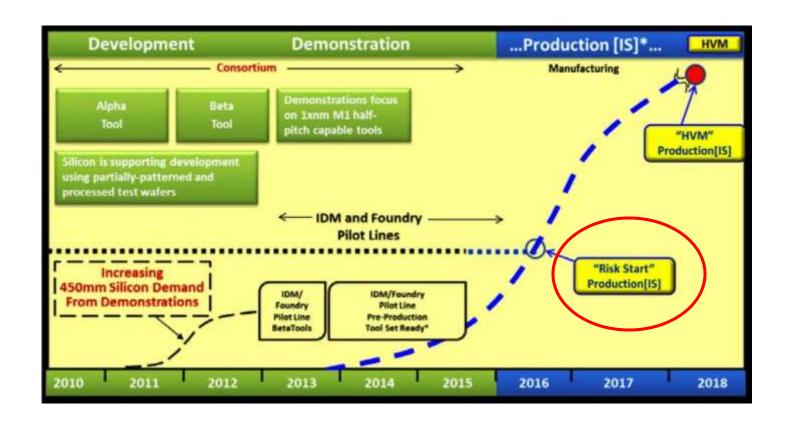
And reduced equipment purchases – 1.5% per year growth since 300mm equipment was introduced



Compared to 8.3% growth per year for semiconductors



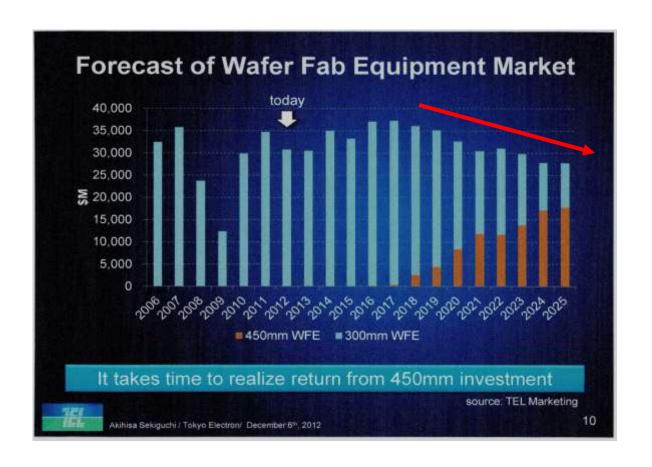
When? ITRS has its roadmap for 450mm wafers - 2016



Implication 1 - Not many fabs will be built with a >\$10B price tag – only the largest will benefit



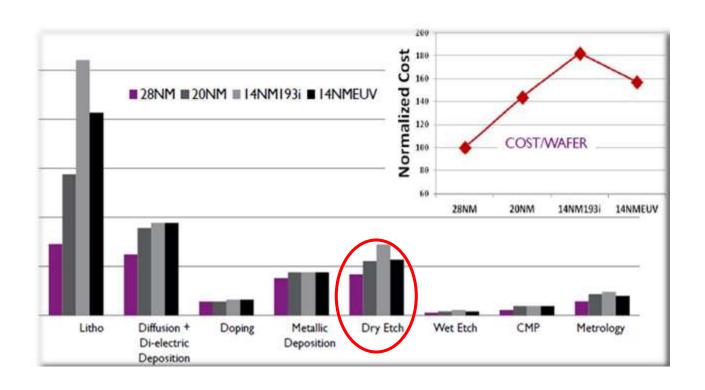
Implication 2 – While 450mm equipment will be up overall equipment revenues down



EUV Lithography

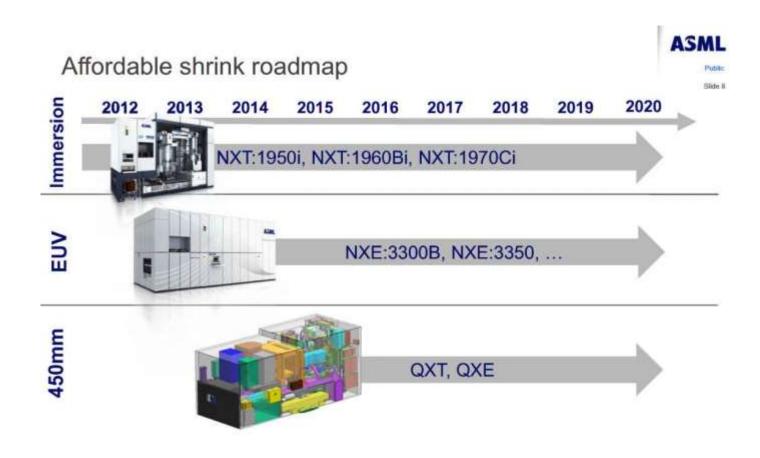
Why? When? What are the Implications?

Cost - Without EUV manufacturing cost would escalate 80% at 14nm – overall and for plasma etch

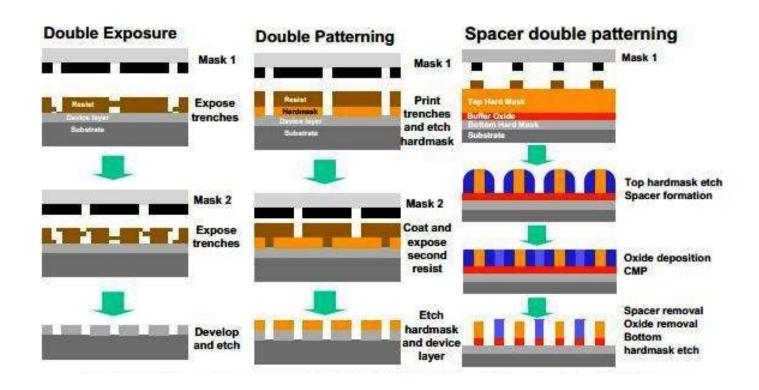


Source: IMEC

Some Pushouts in EUV until 2014 but still ready for 450mm wafers at 10nm in 2016



Implication – EUV eliminates need for multiple patterning that extends DUV - Etch processes are also eliminated



22/14nm

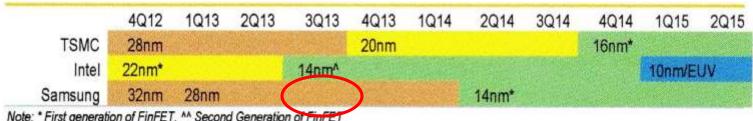
Why?
When?
What are the Implications?

Smaller features give improved performance and extends Moore's Law



Source: Achronix

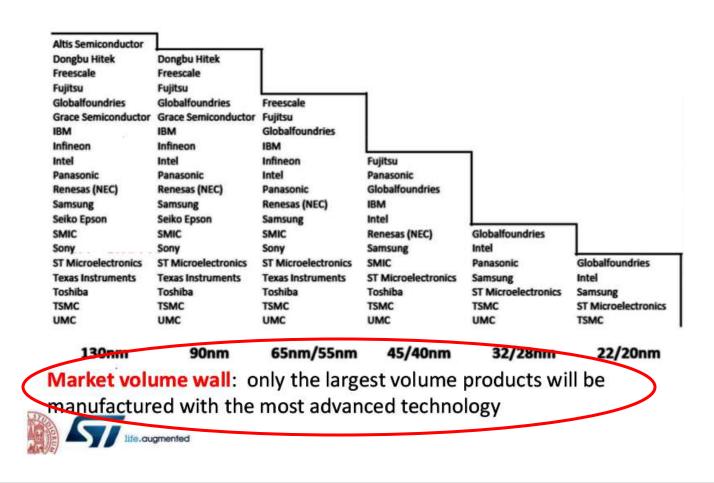
Intel is ahead at 14nm but defects have pushed out start until 2014



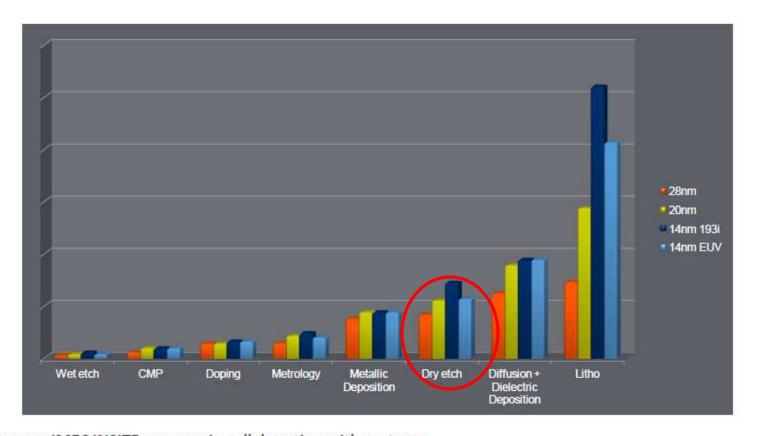
Note: * First generation of FinFET, ^^ Second Generation of FinFET

Source: Company data Maybank Kim Eng

Implication 1 - Only a few companies will implement 22/14nm initially



Implication 2 – Etch cost jumps at 14nm without EUV because of multiple patterning

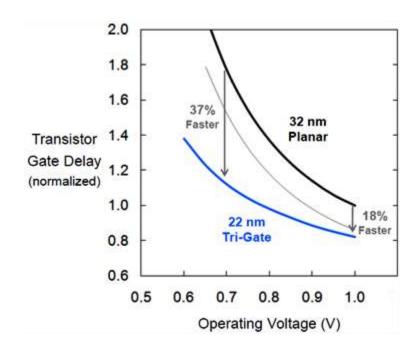


Source: IMEC INSITE program in collaboration with partners

Why? When? What are the Implications?

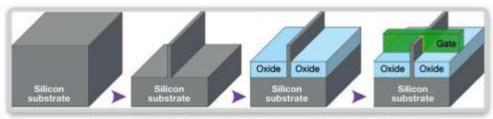
Why 3D?

- Excellent short channel control in FinFET leads to improved performance
 - Lower leakage (lower DIBL and lower SS)
 - Low Vt variability due to low channel doping
 - Less variability caused by random dopant fluctuations
 - Lower operating voltage -> 50% dynamic power savings

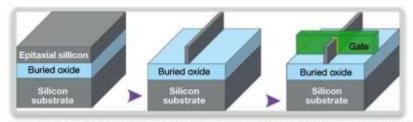


Source: Intel

Intel's FinFETs took an early lead but FD-SOI has benefits



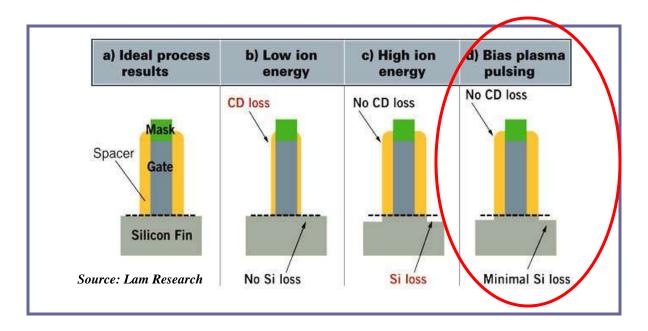
Normal Wafer: FinFETs on regular wafers rely on a timed etch to form the fins



Silicon-on-Insulator Wafer: FinFETs on SOI wafers rely on the buried oxide layer to stop the fin etch

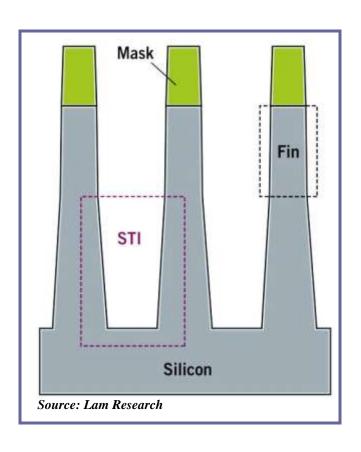
- Cheaper: Lower overall cost
- Faster time to market, up to one year earlier
- Simplified manufacturability with fewer process modules to develop
- Better: Improved variability and electrical characteristics

What does all this mean for plasma Etch equipment?



Bias pulsing offers a viable approach to achieve directional etching with minimal structural damage that will be needed for manufacturing FinFET devices according to Lam Research

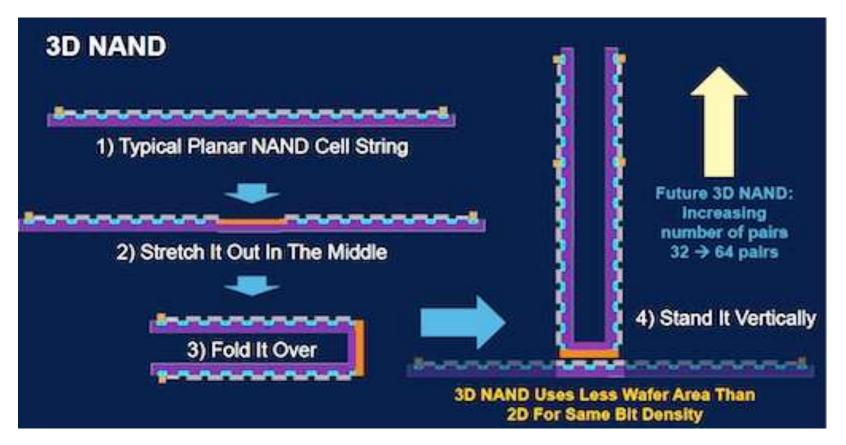
Implication- Greater need for advanced plasma Etch



For a FinFET Fin

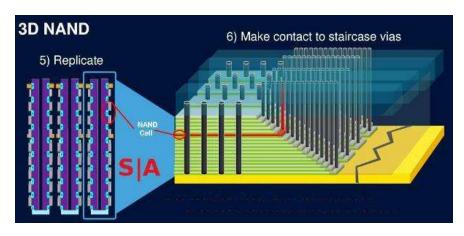
- STI structure and fin are etched simultaneously
- Etch process creates the actual channel (the fin), so producing a precisely vertical fin with low surface state density is critical.

3D NAND - Instead of one transistor layer then metal layers above it (Dep/Etch), you lay wown 32+ layers of mixed transistor and metal



Source: Applied Materials

3D NAND – Extremely complex processing but 3D means relaxed linewidths – 19nm planar node is ~50nm rule



Source: Applied Materials

Staircase etching - Put down as many layers as you need with horizontal traces then etch them out layer by layer forming a staircase pattern. Then you put in vertical vias down to these exposed horizontal traces

The advantage of 3D NAND is that it doesn't require leadingedge lithography...the burden will shift from lithography to deposition and Etch

PLANAR

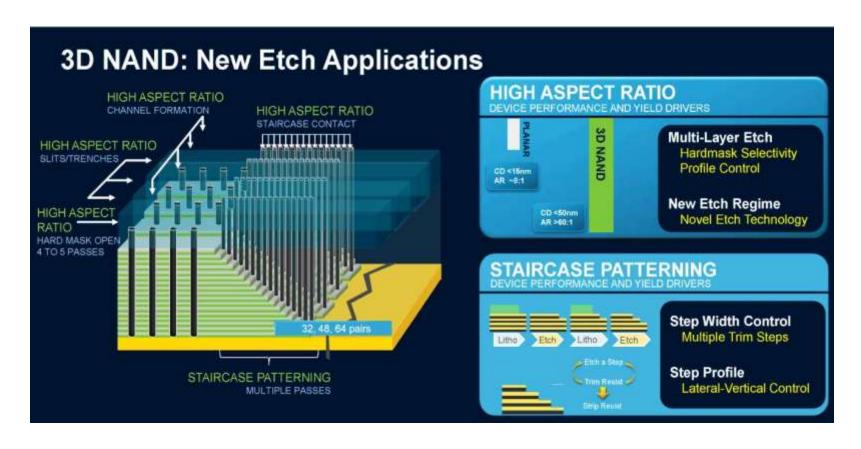
- CD DEFINITION AND SCALING (<15nm)
 - Lithography
- ETCH
 - Lower aspect ratios
 - Multi-patterning (SATP, SAQP)
- DEPOSITION
 - o Single layer
 - Thinner films

Source: Applied Materials

3D NAND

- CD DEFINITION AND SCALING (~50nm)
 - Etch and Deposition Grows
 - Lithography drops
- ETCH (+30 to +40%)
 - High aspect ratios
 - Staircase patterning (trim and etch)
- DEPOSITION (+50 to +60%)
 - Multi-layer stacks
 - Thick films (active and hardmask)

3D NAND introduces many new Etch applications



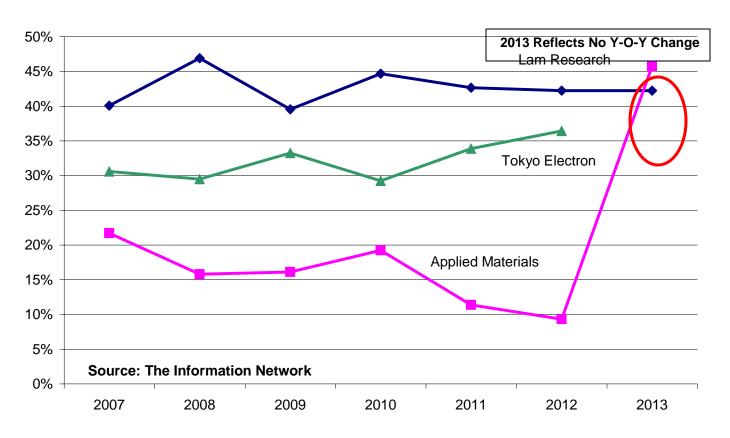
Source: Applied Materials

And new revenue opportunities in Etch



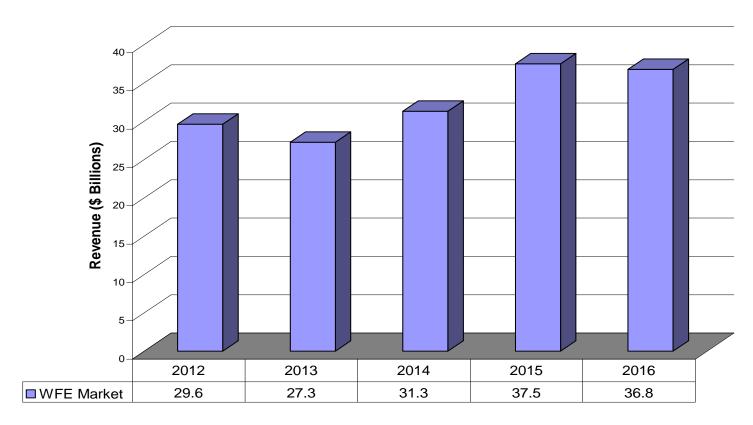
Applied Materials key beneficiary of merger for Etch





Positive growth for overall equipment in 2014 and 2015 – plasma etch market represents about 14% of overall market

Wafer Front End Equipment Growth



Source: The Information Network

Thank You